



Docket No.: 8733.307.00-US
(PATENT)

AF/2823
#22
JF
6/6/23

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Oh-Nam Kwon

Application No.: 09/709,483

Group Art Unit: 2823

Filed: November 13, 2000

Examiner: Pham, Thanh V.

For: METHOD OF MANUFACTURING A THIN
FILM TRANSISTOR

REPLY UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 2800

Dear Sir:

In response to the Final Office Action dated February 25, 2003 the following remarks are respectfully submitted.

REMARKS

At the outset, the Examiner is thanked for the thorough review and consideration of the subject application. The final Office Action of February 25, 2003 has been received and contents carefully reviewed.

Claims 1-13 are currently pending in the present application. Reexamination and reconsideration is respectfully requested.

Regarding the need for corrected drawings, included herewith is a copy of the Request for Examiner Approval of Drawing Changes previously submitted with a copy showing the corrections in red.